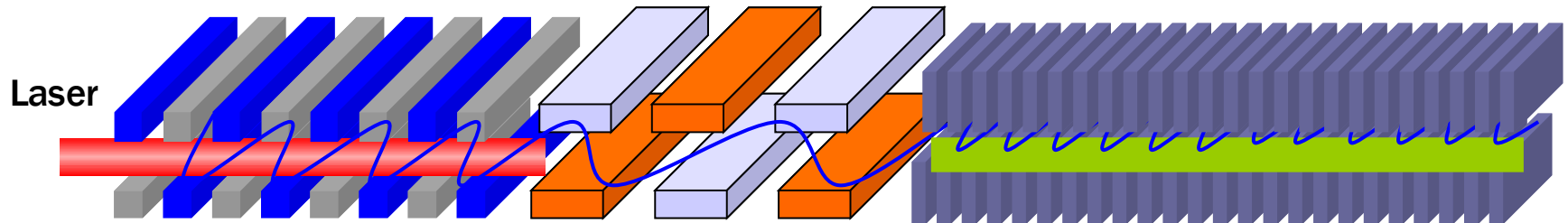


APPLE Undulators for HGHG FELs



- ⊕ **HGHG Projects**
- ⊕ **Cascaded HGHG, The BESSY Soft X-Ray FEL**
- ⊕ **Undulator Magnet Design, APPLE III**
- ⊕ **Magnetic Material and Field Optimization**
- ⊕ **Support and Drive System, Motion Control**
- ⊕ **Operation Issues, Focussing Effects**
- ⊕ **Machine Protection**



energy modulation
of the electron
beam (**Modulator**)

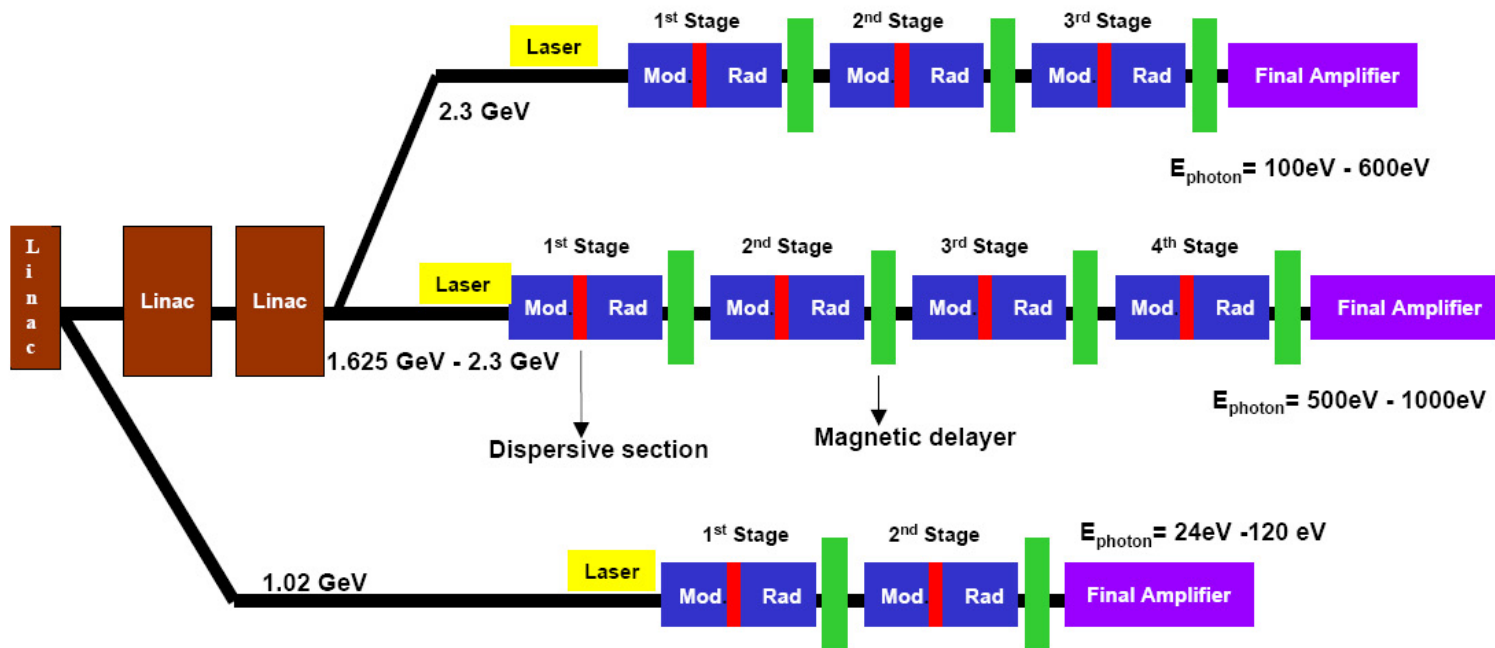
spatial bunching
optimized for a
particular harmonic

resonant to the
harmonic (**Radiator**)

*L.-H. Yu et al., BNL
Phys. Rev. A44/8 (1991) 5178*

	DUV	FERMI I / II	EUROFEL	BESSY	ARC-EN-CIEL I / II	SDUV
λ / nm	265 / 100	40 / 10	89 / 53	51 - 1	≤ 66 / 1	89
Electron energy / MeV	175 / 300	1200	450	1000 / 2300	220 / 1000	276
Stages	1	1 / 2	1	2 / 3 / 4	1 / 1	1
Status	operational / proposed	funded	construction	proposed	proposed	proposed

The planned BESSY HGHG FEL facility consists of three HGHG lines to cover the energy range from 24eV to 1000eV



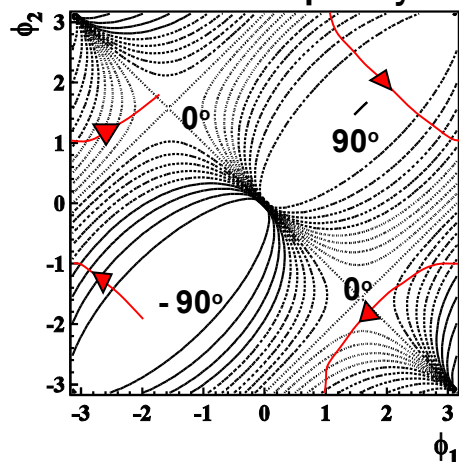
period length in mm and module length in m

	LE-FEL		ME-FEL		HE-FEL	
Energy range	24 – 120 eV		100 – 600 eV		500 – 1000 eV	
	Modulator	Radiator	Modulator	Radiator	Modulator	Radiator
Stage 1	80 1,60	62 3,47	122 2,20	92 3,68	122 2,20	92 3,68
Stage 2	62 1,61	50 3,45	92 2,02	70 2x3,36	92 2,02	70 2x2,73
Stage 3			70 2,10	50 3x3,45	70 2,1	50 3x2,9
Stage 4					50 3,45	28,5 2x3,135
Final amplifier	50 3x3,45		50 5x3,45		28,5 5x3,135	
Total length	20,48 m		44,88 m		49.555 m	

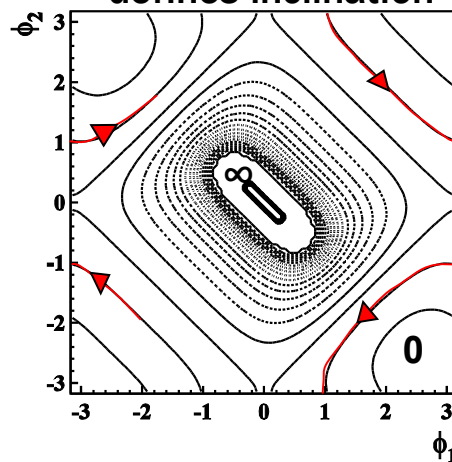
Features of APPLE design:

- parallel motion : hor. / vert. linear und elliptical / helical polarization
- antiparallel motion: linear polarization with angles 0 - 90°
- 4 movable rows : linear polarization with angles 0 - 180°
- compensation of polarizing effects of the beamline optic with undulator
any arbitrary polarization ellipse can be produced:

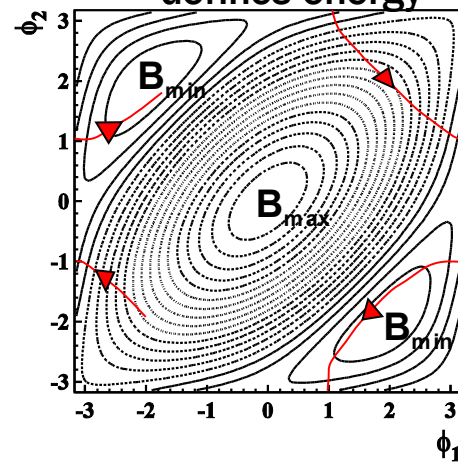
relative phase of B_y , B_z
defines ellipticity



ratio B_y / B_z
defines inclination



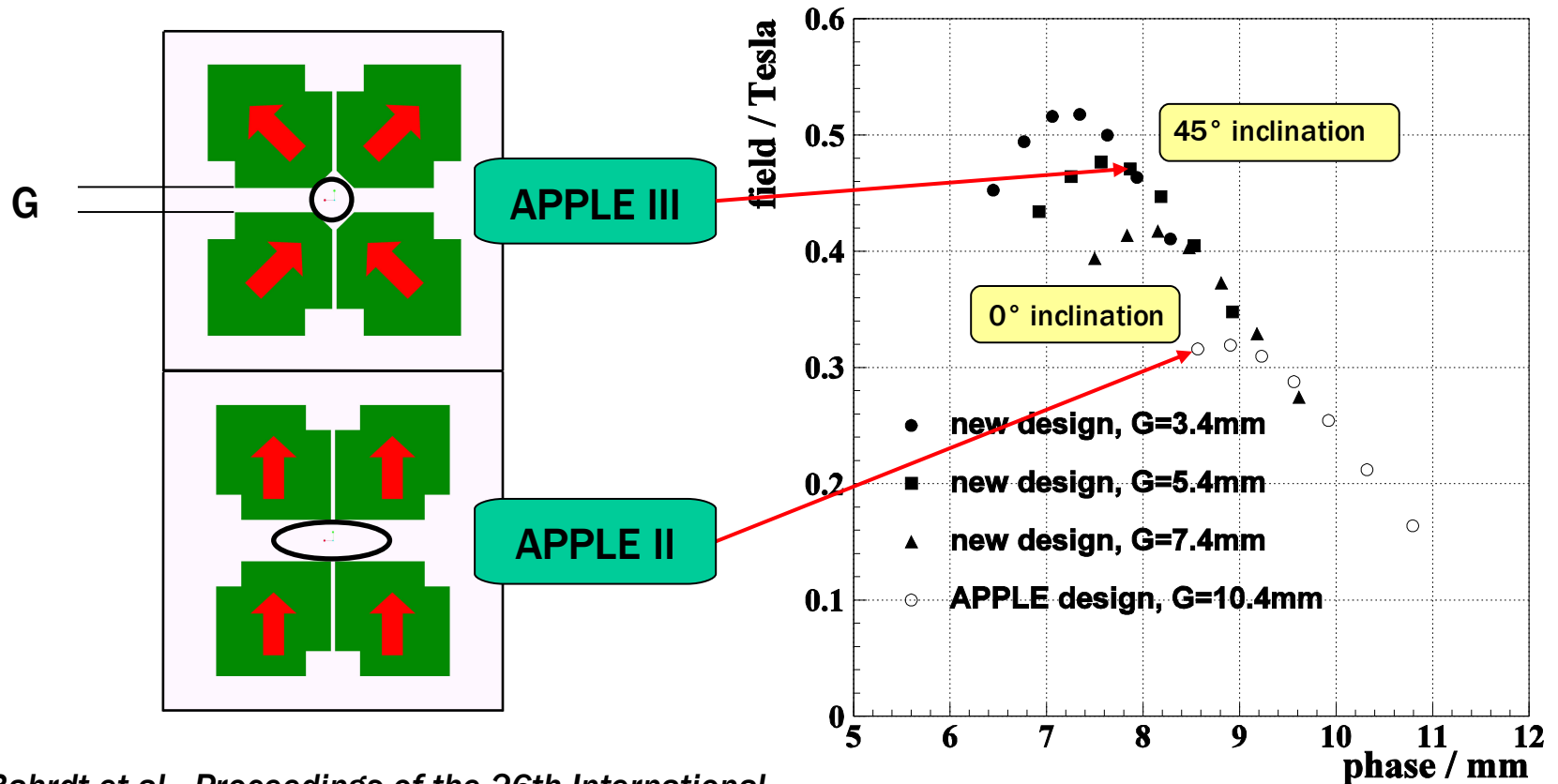
effective field
defines energy



The APPLE III Design

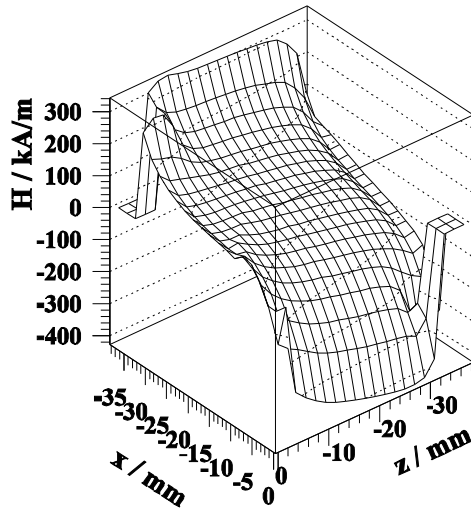
last Radiator and final amplifier have a new design

APPLE III design: **factor 1.4 higher field as compared to APPLE II**

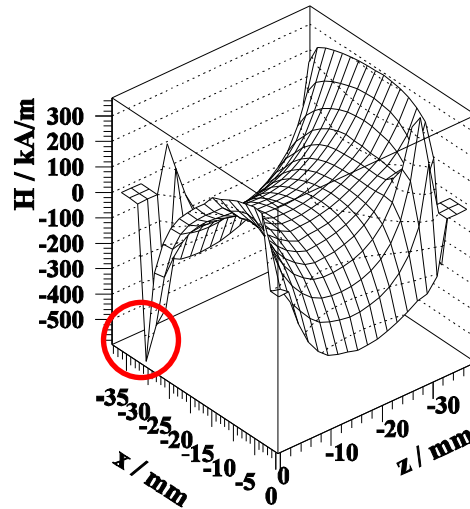


J. Bahrtdt et al., Proceedings of the 26th International FEL Conference, Trieste, Italy, 2004, pp610-613

APPLE III - APPLE II



A-magnet



B-magnet

- plotted are the strongest reverse fields among all combinations within
- entire gap range
 - entire shift range
 - various operation modes
 - entire z range within magnet

choosing slightly different magnet grade for APPLE III recovers magnet stability:

typical values

grade	Br / Tesla	Hcj / kA/m
655 TP	1.26	1910
677 TP	1.18	2465

Trajectory errors

$\int \int B \, dl \, dl' < 0.1\sigma$ of photon / electron beam $\approx 5\text{-}10\mu\text{m}$

$\int \int B \, dl \, dl' < 17 \text{ Tmm}^2$ @ 1.0 GeV **achievable with state of the art techniques**
 $< 38 \text{ Tmm}^2$ @ 2.3 GeV

Phase errors

phase errors due to energy spread dominate over field errors if

$\Delta\Phi_{\text{rms}} < \sigma / \gamma\rho 1.73 \approx 6.6^\circ$ for the HE-FEL, **achievable with sorting**

Multipole errors

less critical for single pass devices

Systematic field errors

$\Delta K / K \approx 5 \times 10^{-4}$ \rightarrow energy shift < 0.16 of bandwidth

\rightarrow gap positioning accuracy $< 2\mu\text{m}$ $\rightarrow \Delta K / K = 2 \times 10^{-4}$ **demonstrated**

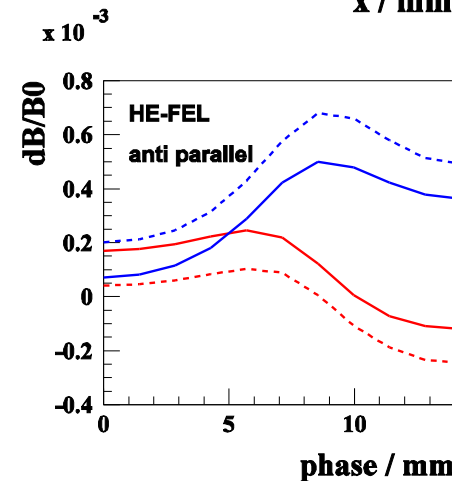
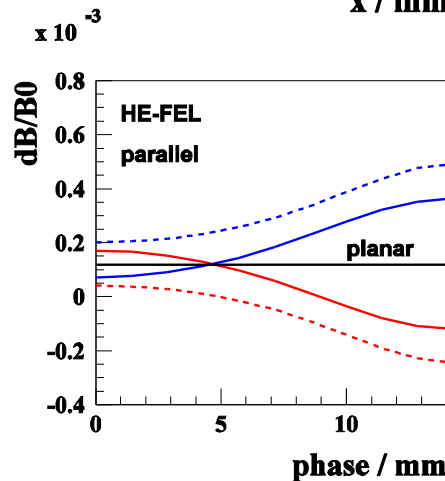
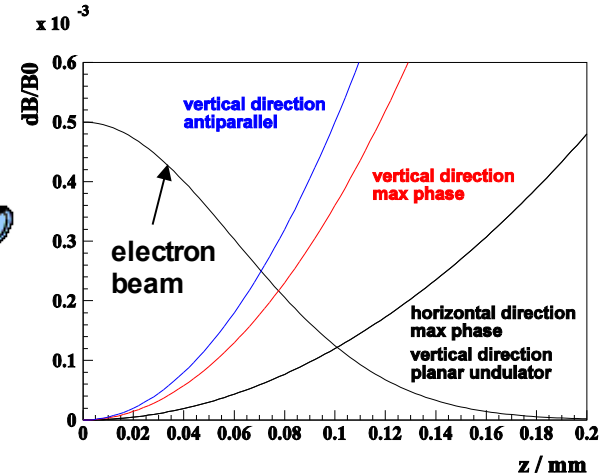
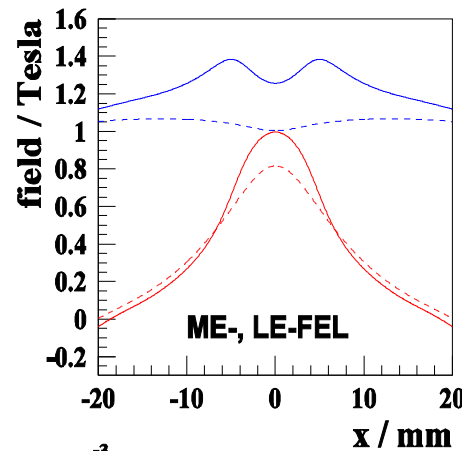
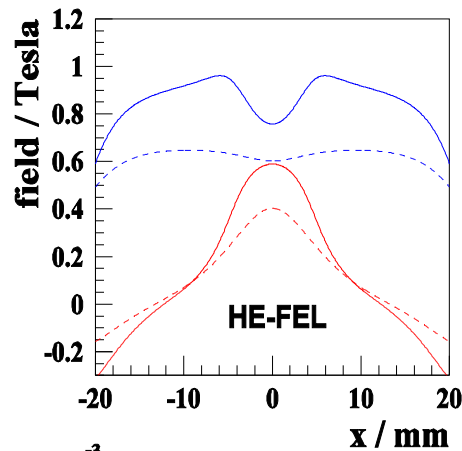
\rightarrow temperature stability of magnets: $\Delta K / K = 2 \times 10^{-4}$ for $\Delta T = 0.2^\circ\text{C}$

temperature control of tunnel

\rightarrow transverse alignment tolerance $< 40\mu\text{m}$ $\rightarrow \Delta K / K = 2 \times 10^{-4}$

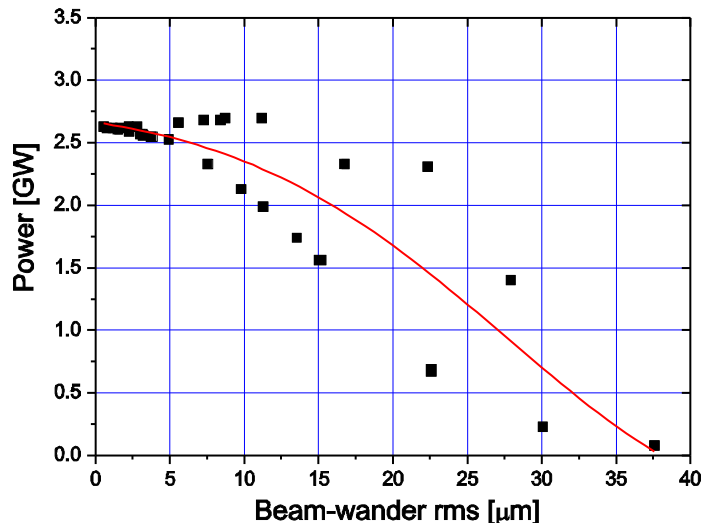
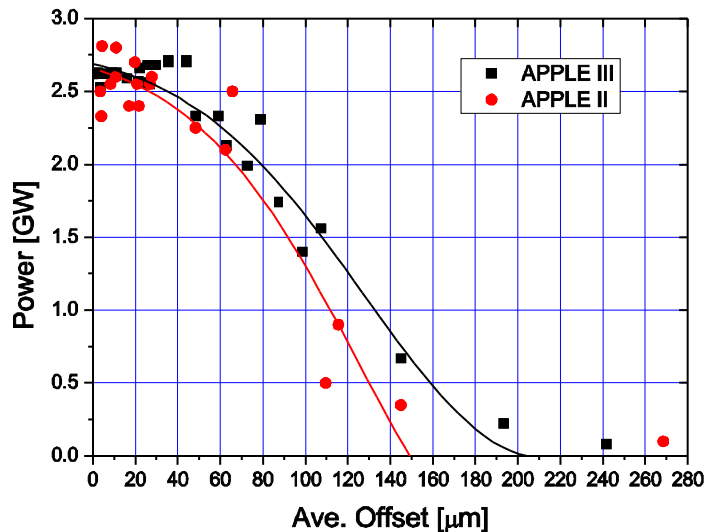
stiff structures for antiparallel motion, movable stages

Good Field Region of APPLE IDs



blue: vertical field
red: horizontal field
solid: APPLE III
dashed: APPLE II

tight alignment tolerances in **both** transverse directions  support structure
APPLE III (solid) slightly relaxed as compared to APPLE II (dotted)



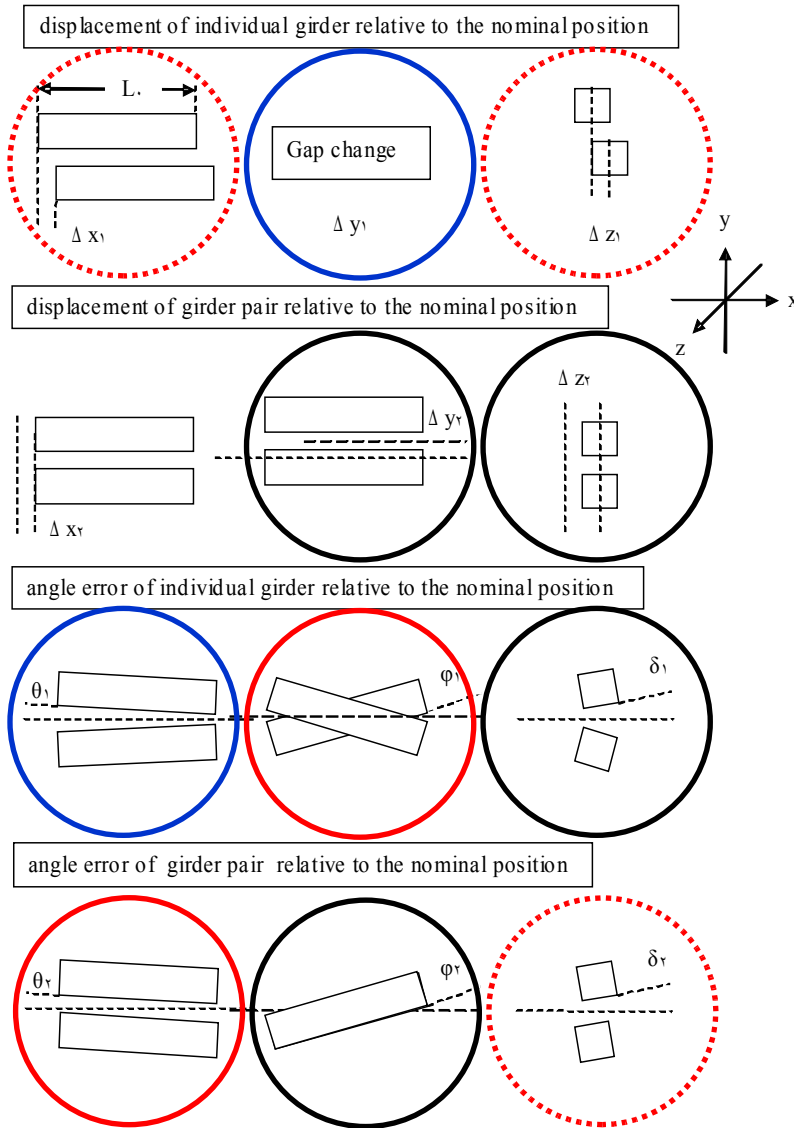
tolerance studies on the transverse positioning accuracy for APPLE III undulator (BESSY HE-FEL)

random transverse displacement of final amplifier undulator modules

simulation of trajectory wander and power degradation using GENESIS

40μm displacement is acceptable.

A. Meseck, J. Bahrdt, 27th, International FELConference, Stanford, Ca, 2005, pp47-50



Colour

black:

blue:

red, dotted:

red, solid:

Solution

independent on forces
**accuracy and stiffness of
of support structure**

closed loop servo systems

dependent on forces
appears in inclined mode
produces K-shift
stiff support structure

dependent on forces
appears in inclined mode
produces $\Delta K/K$ -shift
**feed forward / back
compensation using 4 motors**

dynamic multipoles: second order effect

no straight line integrals, not measurable with moving wire

$$\theta_{x/y} = - \frac{\lambda}{(B\rho)^2} \int \left\{ \int B_x dz' \cdot \frac{\partial B_x}{\partial x/y} dz' + \int B_y dz' \cdot \frac{\partial B_y}{\partial x/y} dz' \right\} dz$$

$$\int B dl \propto B \cdot \frac{\partial B}{\partial z} \cdot \frac{\lambda_u^2}{E^2}$$

*P. Elleaume, Proceedings of the
EPAC 1992, pp 661-663*

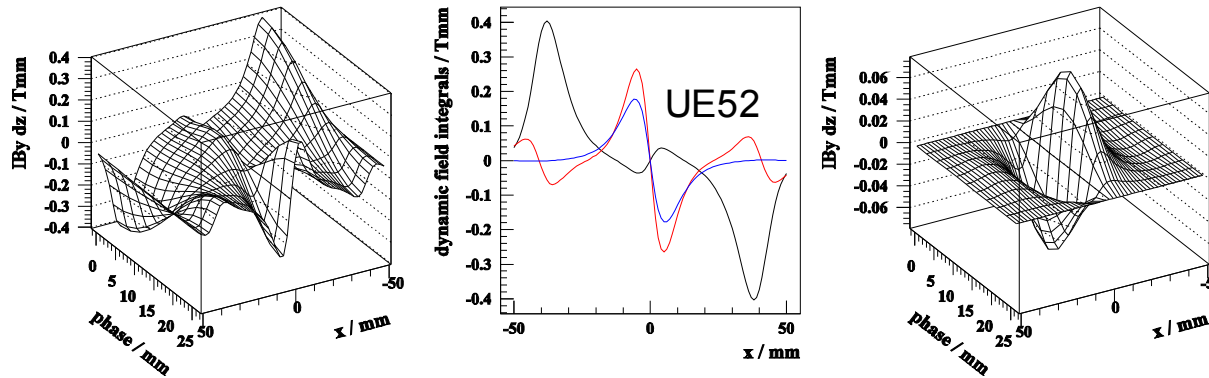
have to be regarded at:

- low and medium electron energies (less critical for X-FEL)
- long period lengths
- high fields, large transverse gradients (e.g. high field wiggler, APPLE)

responsible for:

- natural vertical focussing, horizontal defocussing (APPLE)
- impact on dynamic aperture via higher order terms
(less important for single pass devices)

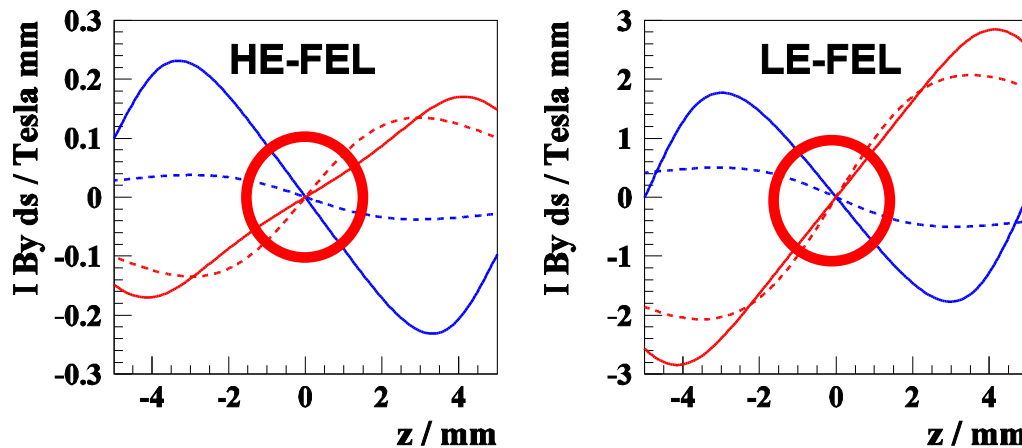
Dynamic Multipoles II



$$\theta_x(x) = f_0(x) \cdot \cos(\varphi / \gamma) + f_\pi(x) \cdot \sin(\varphi / \gamma) + f_{\pi/2}(x) \cdot \sin(\varphi)$$

f_0
 f_π
 $f_{\pi/2}$

3 generic functions



blue: phase = 0

red: phase = π

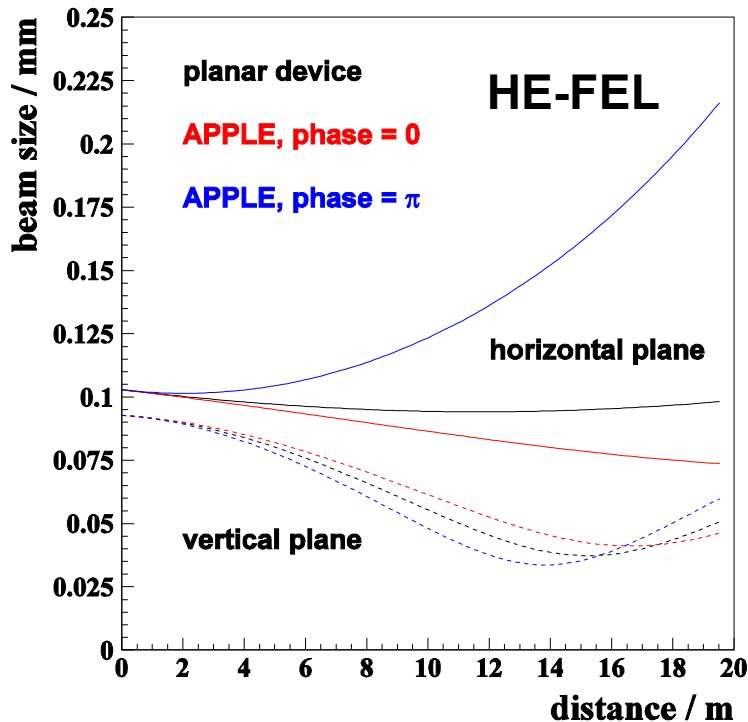
solid: APPLE III

dashed: APPLE II

(field scaled to
APPLE III value)

module length: 3m

dynamic quadrupole modifies the electron beam size



$$K_x = \frac{\gamma \cdot e}{(\gamma mc)^2} k_{x-eff} \cdot k \cdot \left(\sum_{n=1}^{\infty} (B_{xn}^2 + B_{yn}^2) \right)$$

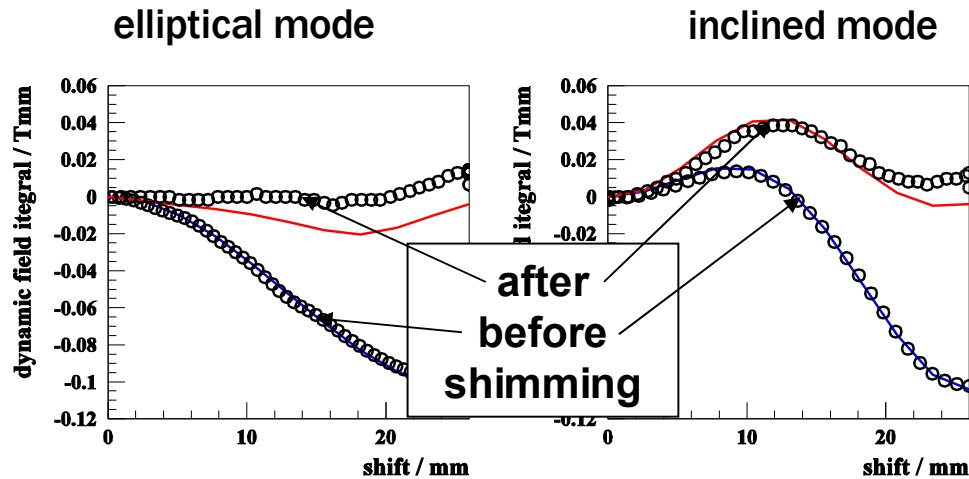
$$k_{x-eff} = \sum_{n=1}^{\infty} \frac{B_{xn}^2 \cdot k_{xxn} / n! + B_{yn}^2 \cdot k_{xyn} / n!}{B_{xn}^2 / n! + B_{yn}^2 / n!}$$

focussing is stronger for the other FELs
by a factor of:

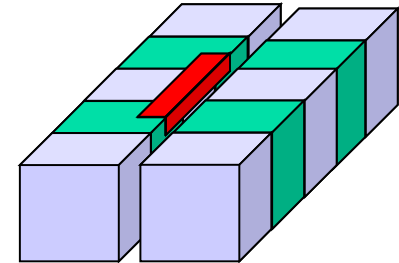
9	ME-FEL
45	LE-FEL

adaptive focussing is essential for optimum
overlap of electron beam and photon beam
effects can partly be compensated with Fe shims

BESSY UE52



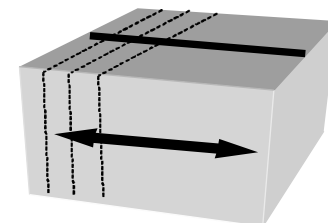
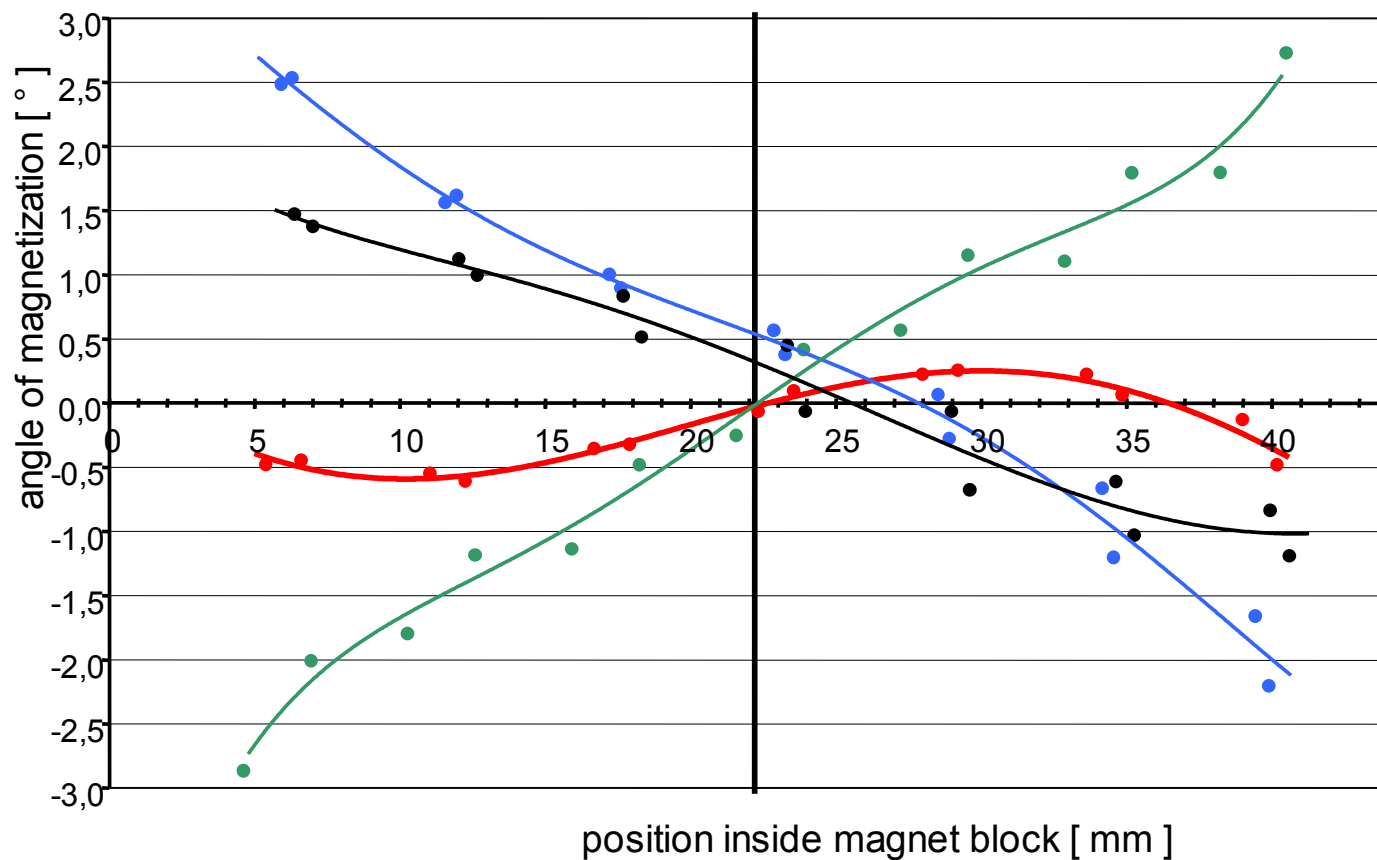
J. Bahrtdt et. al., SRI 2006, Daegu, Korea



J. Chavanne et al., Proceedings of the EPAC 2000, Vienna, Austria, pp 2346-2348

scheme works fine for parallel mode for APPLE II devices
 additional (active) schemes are necessary in inclined mode
 applicability to APPLE III design has to be checked

Magnet Block Inhomogeneities



Helmholtz coil

Courtesy of Vacuumschmelze, Hanau



BMBF-Verbundprojekt:

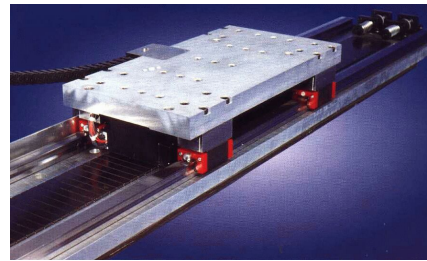
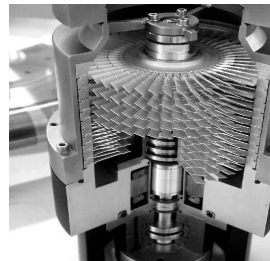
Optimierung der Homogenität von Nd-Fe-B Magneten

Förderkennzeichen: 03X4501A

VAC, BESSY, Associated partners: DESY, SIEMENS, Applied Films

Improved magnet quality will assure:

- reduced time required for block characterization, sorting, shimming
- reduced production cost



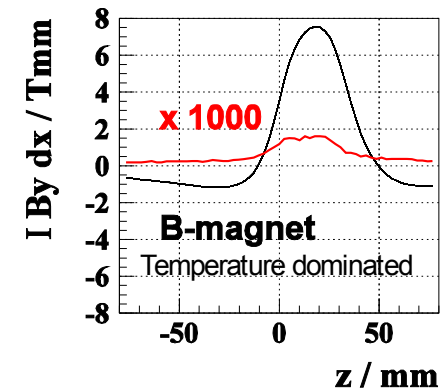
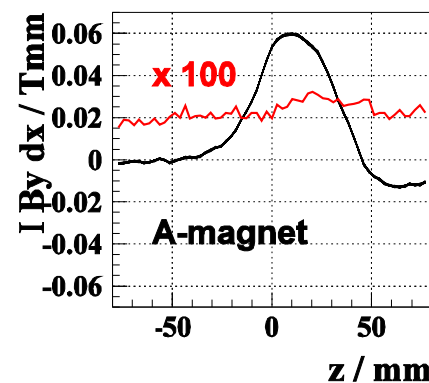
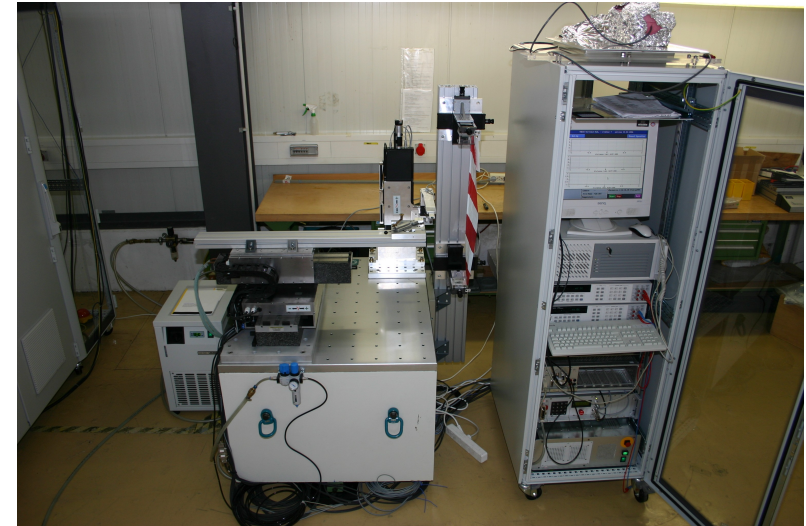
Today, block characterization is essential for an effective sorting
improved magnetic material will reduce production cost

automated Helmholtz coil system for
measurement of dipole moment

stretched wire system for
characterization of inhomogeneities

new measurement setup:
reproducibility:

A-magnets:	2.0×10^{-4} Tmm
	3.0×10^{-4} rel.
B-magnets:	1.5×10^{-3} Tmm
	2.1×10^{-4} rel.

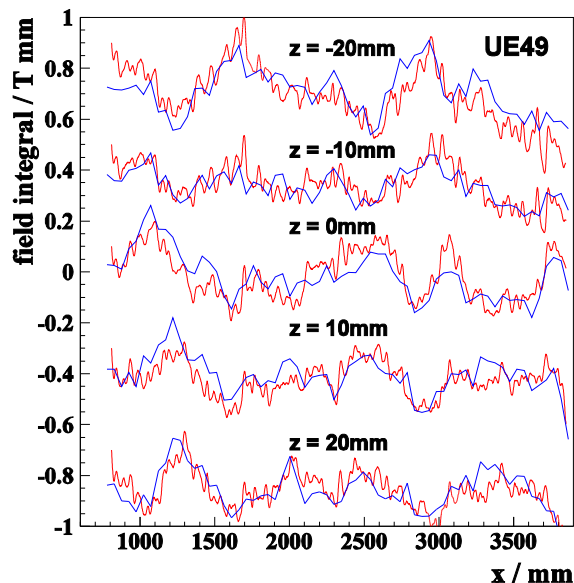


How to meet the FEL-field tolerances

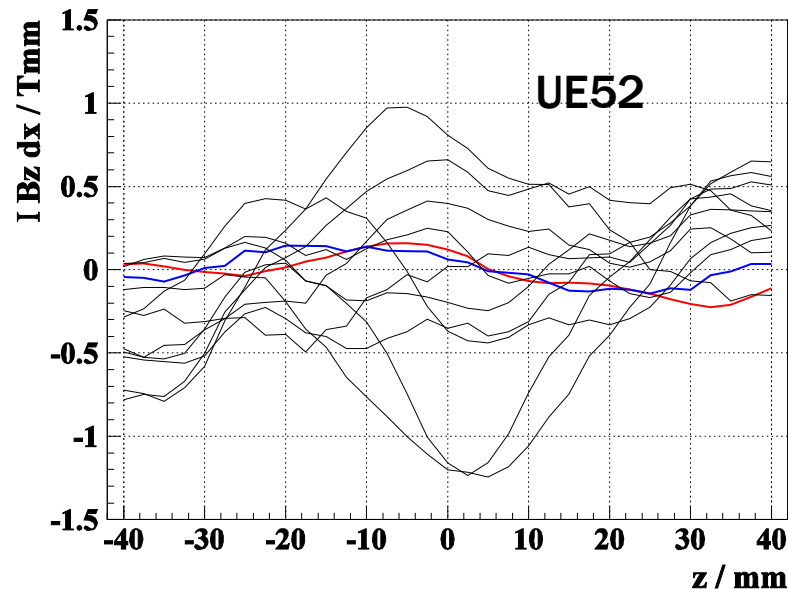
- A) single block characterization and initial sorting and in-situ sorting
- B) shimming

- A) excellent agreement between predicted and measured fields integrals for BESSY undulators UE52, UE49, UE112
- efficient sorting procedure

longitudinal distribution



transverse distribution



blue: prediction
from single block
measurements
red: hall probe
measurements

B) Special shimming techniques for APPLE devices

- trajectory and phase shimming by virtual shimming (transverse block movement)
- shimming of shift dependent field integrals with Fe shims
- shimming of shift independent field integrals with magic fingers
- shimming of dynamic multipoles with FE shims



adjustable permanent magnet arrays
at both ends of the device

*J. Bahrdt, W. Frentrup, A. Gaupp, M. Scheer, U. Englisch,
Nucl. Instr. and Meth. 516 (2004) 575-585.*

handling of strong forces
in all three directions (APPLE),
forces change sign with shift!
tapering



cast iron structures
flexible joints

reproducibility of gap and phase
on $1\mu\text{m}$ level



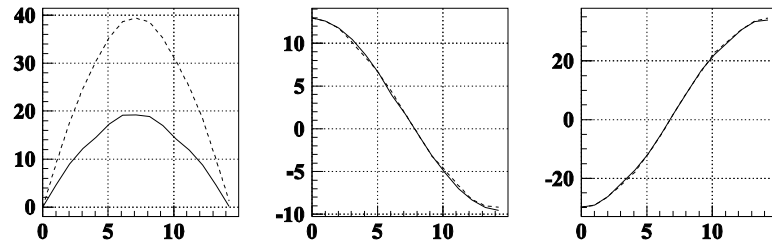
servo motors, feed back loop
advanced measurement concept

optimization of magnet girder

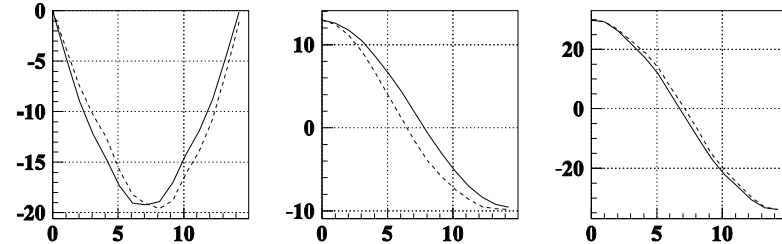


detailed FEM studies

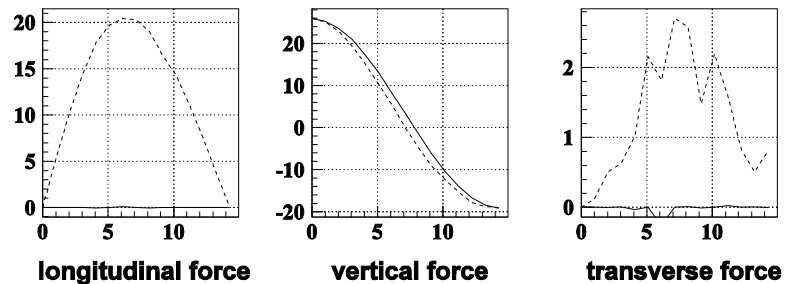
forces on fixed row (kN)



forces on movable row (kN)



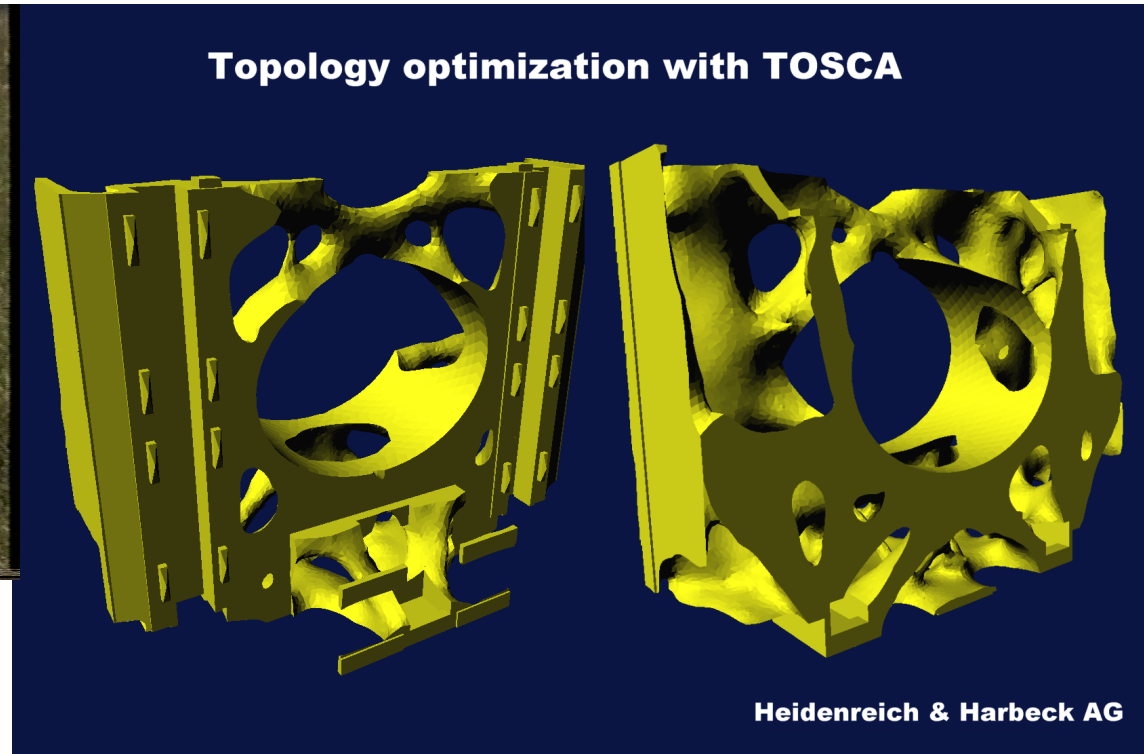
forces on complete I-Beam (kN)



forces of HE-FEL in parallel (solid) antiparallel (dashed) mode
forces of ME- and LE-FEL are roughly a factor of two larger



learning from nature

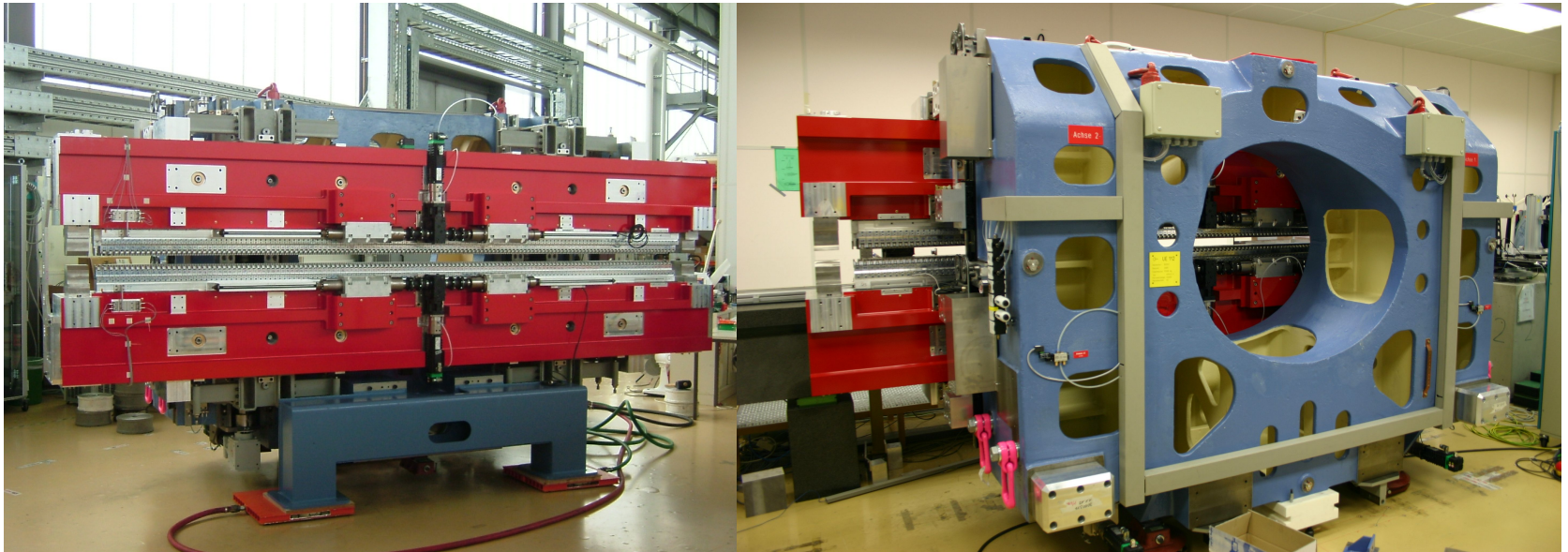


mass reduction at location with low stress
addition of mass at locations with high stress

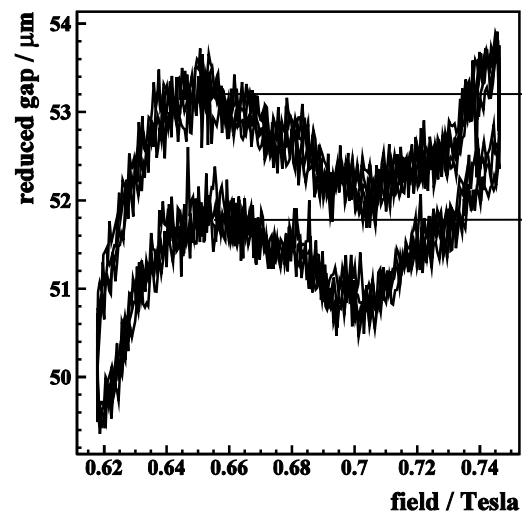
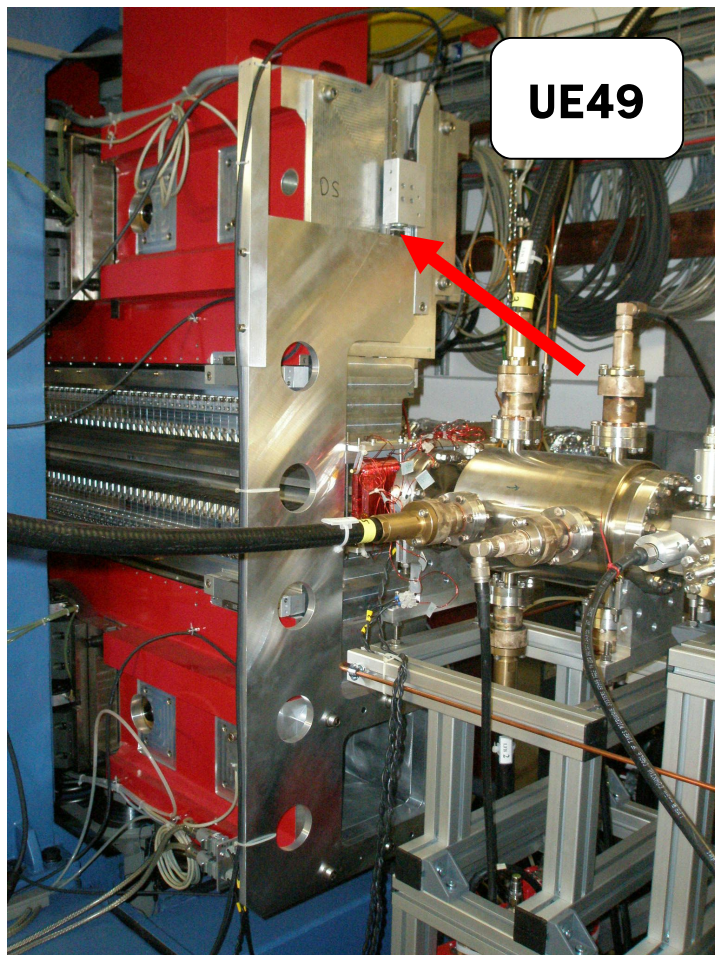
transformation of optimized structure into structures compatible
with existing fabrication techniques is not yet automated

model options for cast iron structures

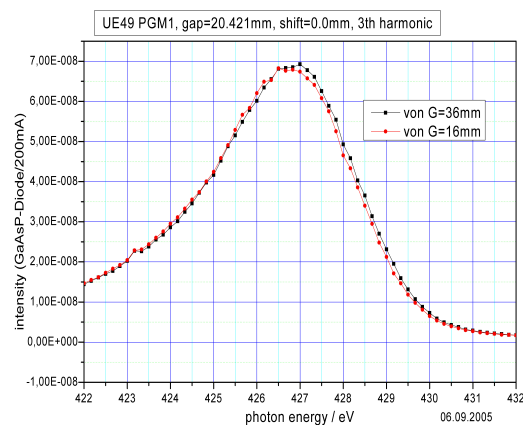
- wooden models:** many casts possible, cost effective for series production
- polystyrene models:** reduced costs for prototype fabrication
- only core model:** reduced costs for prototype fabrication (new technology)



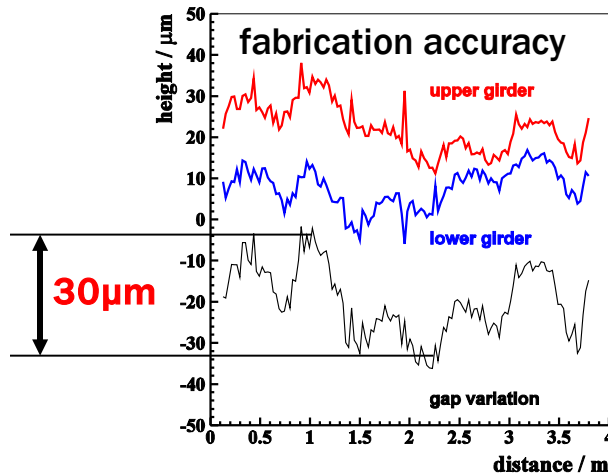
Gap Positioning Accuracy



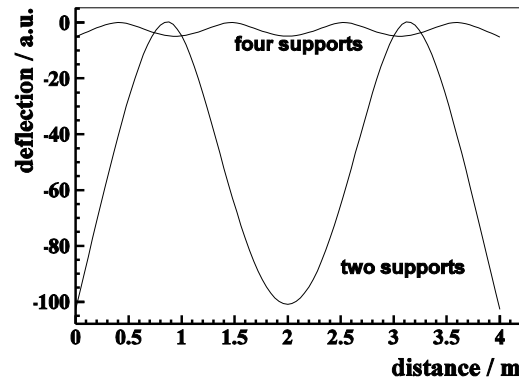
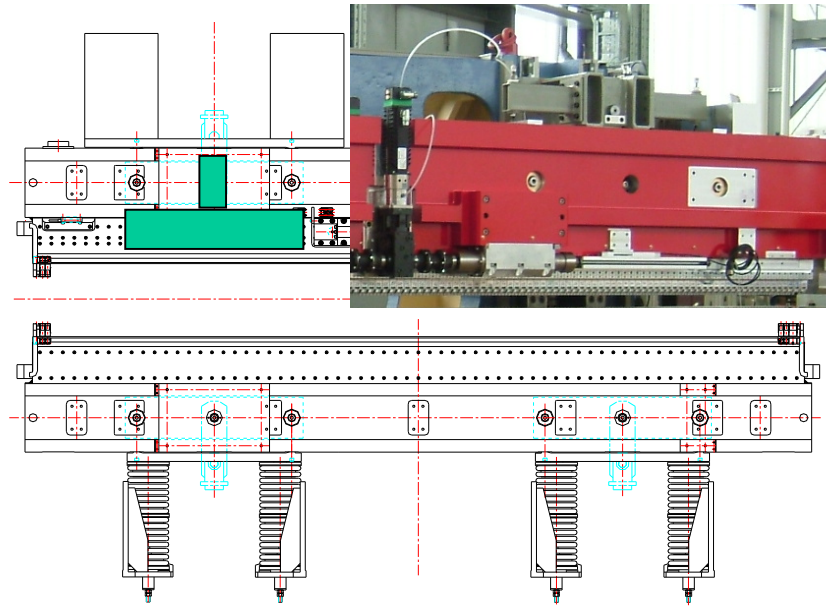
magnetic field
measurement
during gap drive



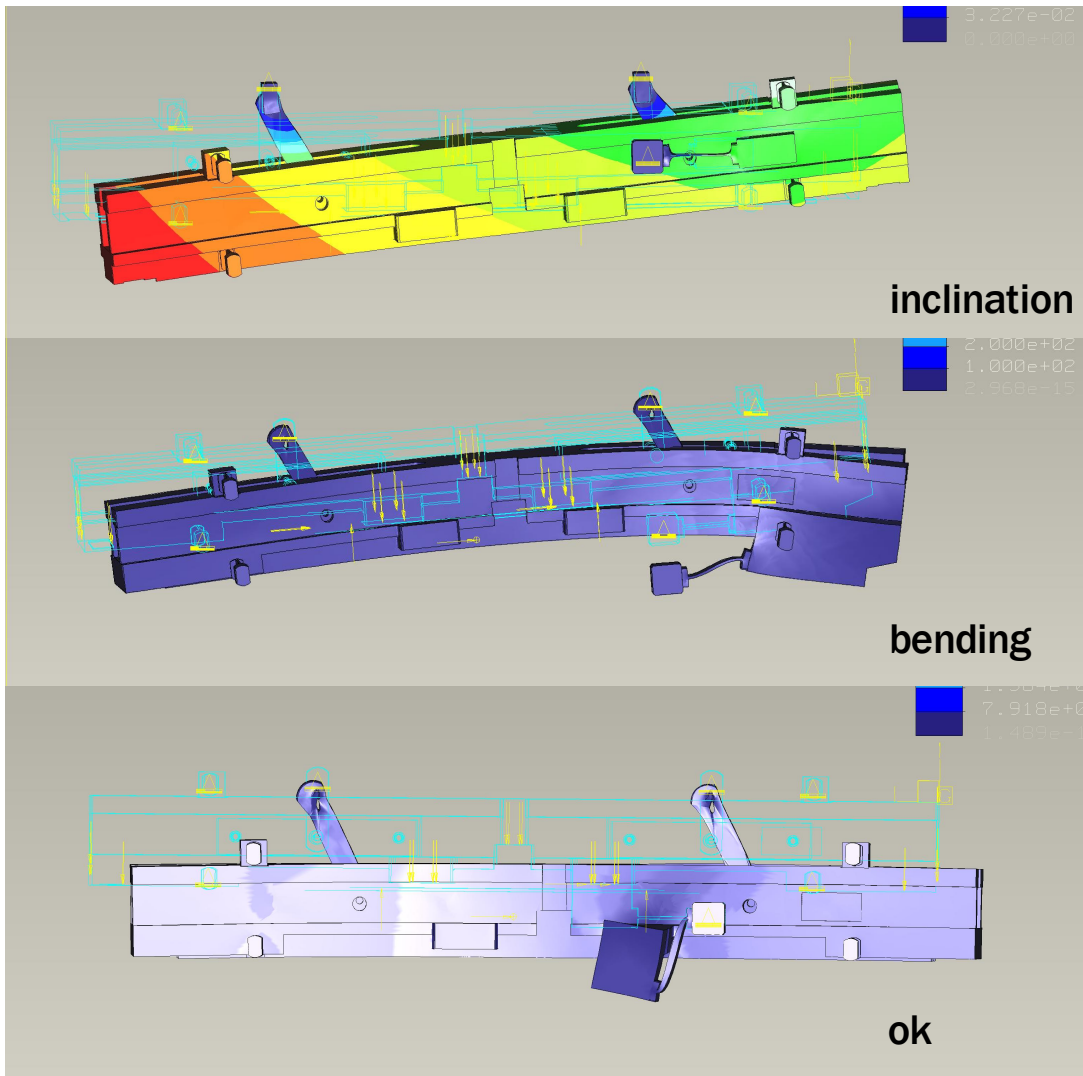
spectra measured
for different
directions of
gap drive



residual fluctuations can be compensated with spacers



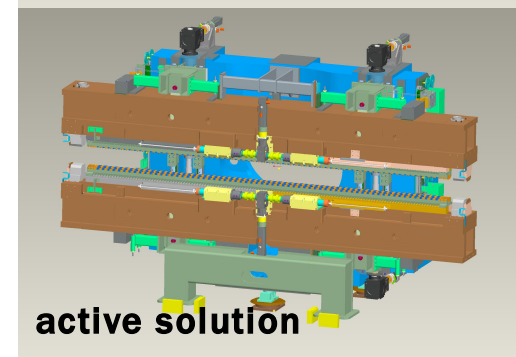
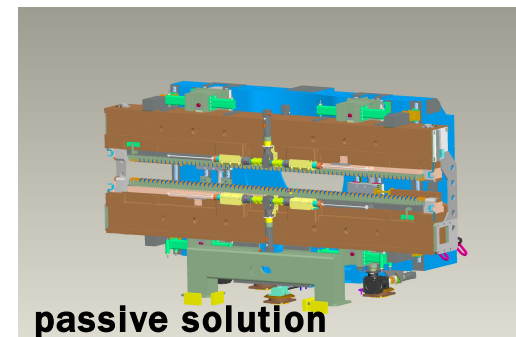
support at four locations for bending minimization (realized at BESSY IDs UE49, UE46, UE112)



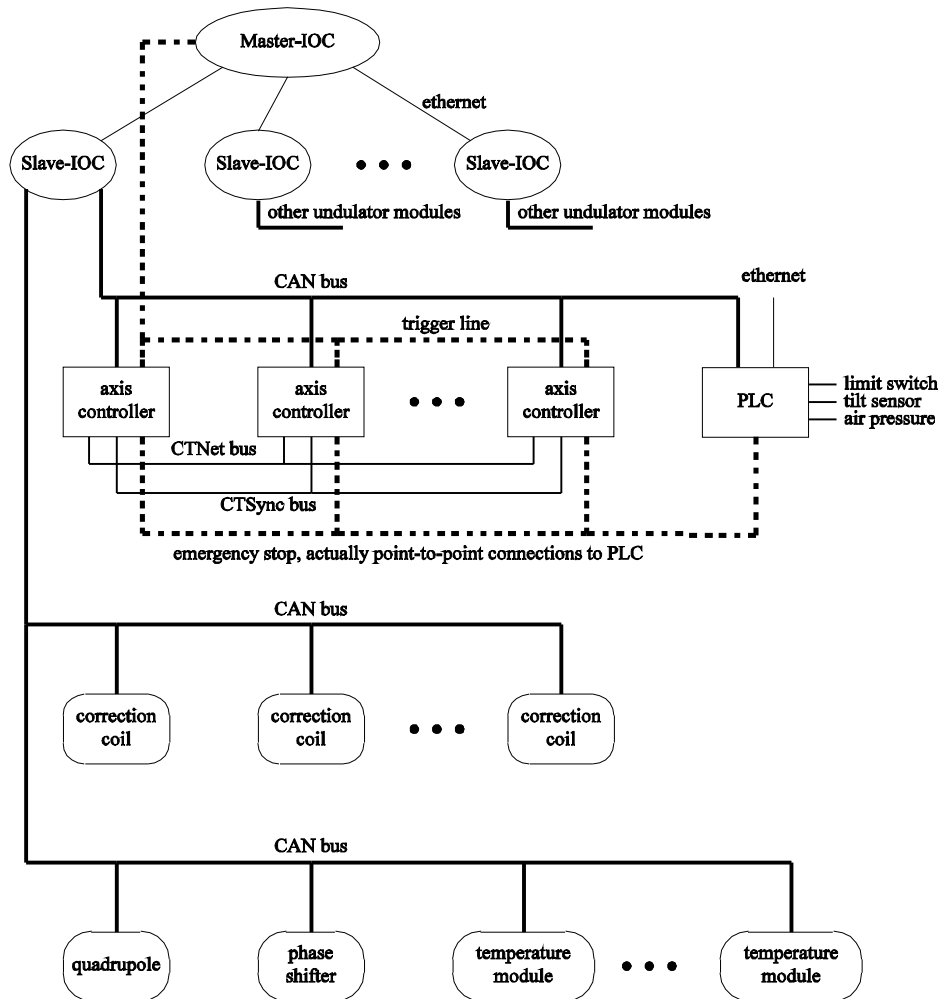
Passive solution:

The correct positioning of the longitudinal fixed bearing is essential to avoid:

5. girder inclination
6. girder bending



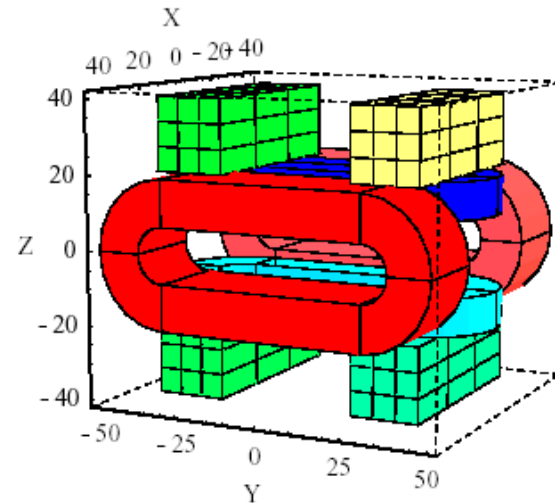
Control System for one module



Reproducibility is required:

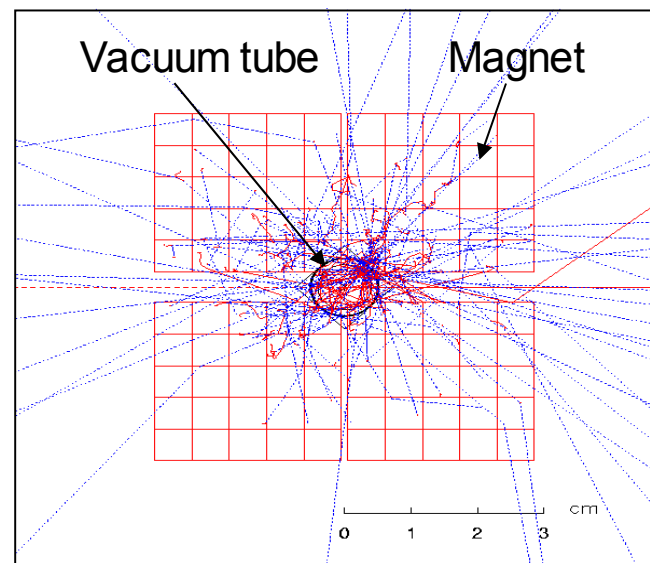
- air coils (no iron)
- permanent magnet quadrupoles
- permanent magnet phase shifter

phase shifter + air coil unit



Model for simulations

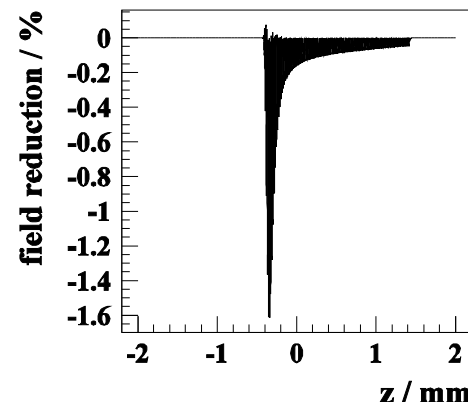
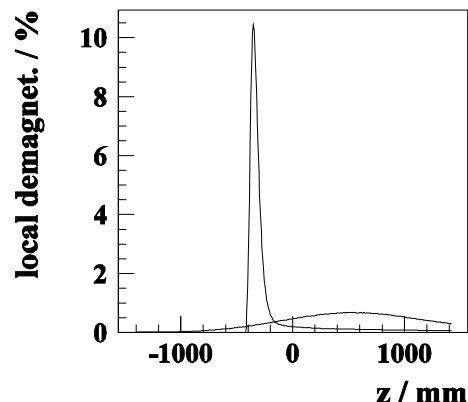
- APPLE III geometry
- circular vacuum pipe
- electron beam hits one magnet row at
 - i) 1 mrad
 - ii) 0.1 mrad
- 70kGray (red. Dose) for 1% remanence loss
- segmentation of magnets:
 - i) 5 x 5 (1 mrad)
 - ii) 7x7 (0.1 mrad)

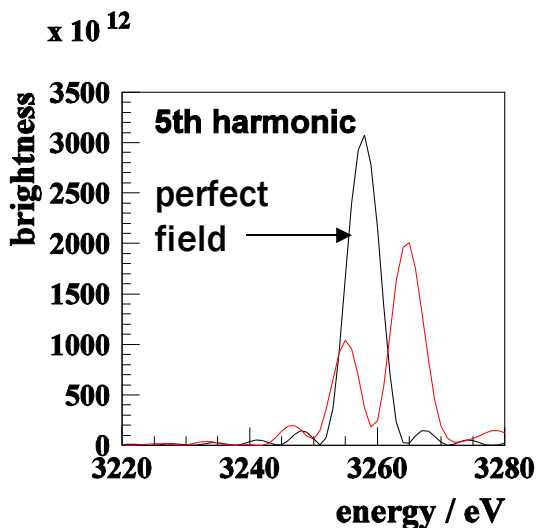
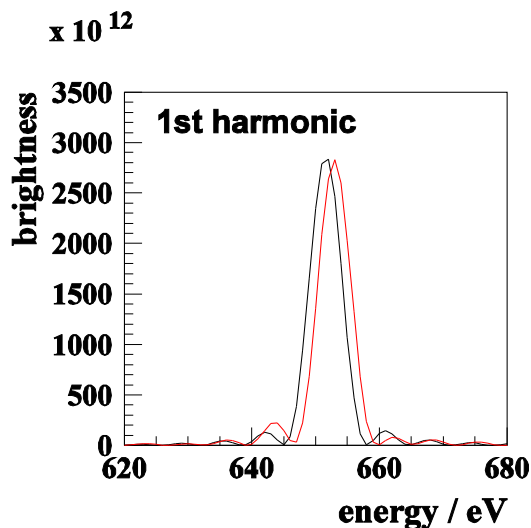
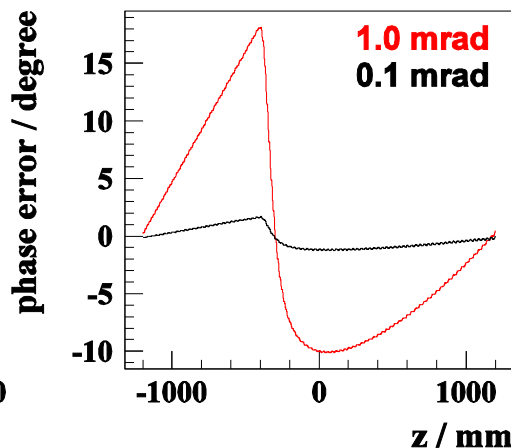
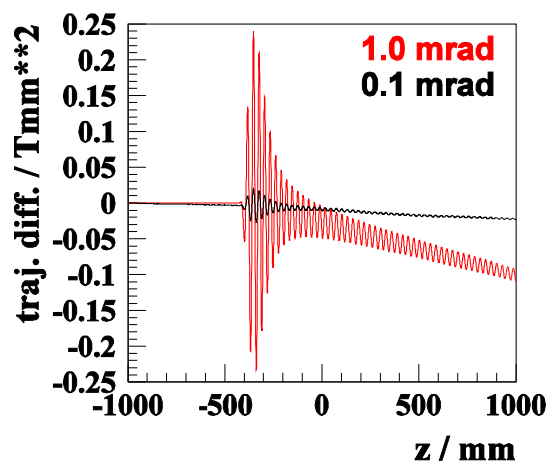


Results

Procedure

- dump 300.000nC into the vacuum pipe at one location
- get doses inside magnet segments
- derive local demagnetization
- get spectra from modified magnets





Results

maximum doses:

0.73 MGy @ 1mrad

0.049 MGy @ 0.1mrad

field reduction on axis:

$\leq 1.6\%$ @ 1mrad

only minimum trajectory error

phase error of $\Delta\Phi = 7^\circ$ @ 1mrad

spontaneous spectrum:

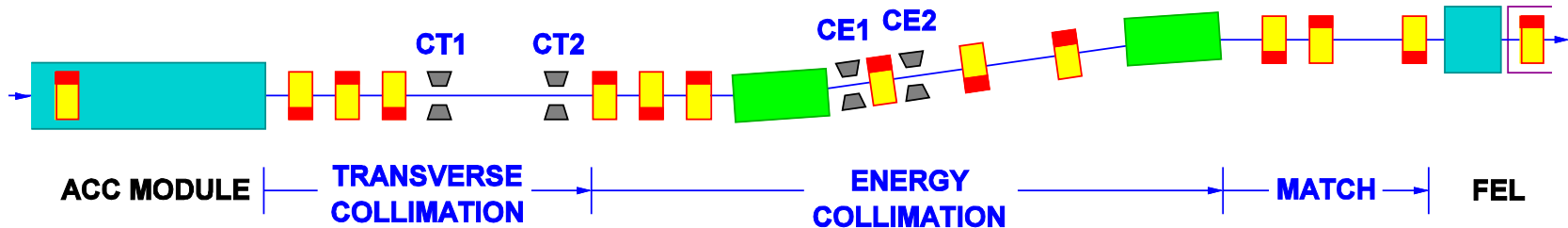
energy shift of 1st harm.

spoilt 5th harm.

phase jump

transverse: $\pm 30 \sigma$

longitudinal: 5%



Experience at FLASH Phase I (with transverse collimator):

maximum detected dose over 3 years = 12 kGy

remeasuring undulator: $\Delta B / B < 2 \times 10^{-4}$

(no changes within measuring accuracy)

PHASE II (dogleg collimator)

a few ten Gy per week for aligned e-beam

- ⊕ Magnetic field tolerances can be achieved with specific techniques
- ⊕ Stiff structures can handle 3D-forces
- ⊕ Closed loop servo systems for gap, phase provide 1 μ m accuracy
- ⊕ Alignment is challenging due to small good field region of APPLE
- ⊕ Complex control system, compensation of undulator focussing
- ⊕ Machine protection system for undulator magnets is required

**H. Bäcker
J. Bakus
W. Frentrup
A. Freter
M. Fuhrmann
A. Gaupp
S. Gottschlich
G. Pfeiffer
M. Scheer
B. Schulz
F. Stahr
H. Wolf**

and many more

